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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant: | Sievers et al. |) | |
| | |) | |
| Serial No.: | 09/887,791 |) | Group Art Unit: 1765 |
| | |) | |
| Filed: | June 22, 2001 |) | Examiner: Ahmed, Shamim |
| | |) | |
| For: | FOCUSED ION BEAM PROCESS |) | |
| | FOR REMOVAL OF COPPER |) | |

AMENDMENT B

Via Facsimile to: 703-872-9310
Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Dear Sir:

This amendment is submitted in response to the Office Action dated May 21, 2003.
Please amend the application as follows: